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CONFIRMATION NO. 3891

SERIAL NUMBER	FILING or 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.		
10/579,036	05/31/2006 RULE	438	1792	7372/88139		
APPLICANTS Kenji Kohiro, Tsukuba-shi, JAPAN; Tomoyuki Takada, Tsukuba-shi, JAPAN; ** CONTINUING DATA ***** This application is a 371 of PCT/JP04/16905 11/08/2004 ** FOREIGN APPLICATIONS ***** JAPAN 2003-382116 11/12/2003 ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 01/09/2007						
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and /FELISA CARLA HITESHEW/ Acknowledged Examiner's Signature		<input type="checkbox"/> Met after Allowance Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 9	TOTAL CLAIMS 8	INDEPENDENT CLAIMS 2
ADDRESS FITCH, EVEN, TABIN & FLANNERY P. O. BOX 18415 WASHINGTON, DC 20036 UNITED STATES						
TITLE Method for manufacturing compound semiconductor epitaxial substrate						
FILING FEE RECEIVED 1030	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:			<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		